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Application Information

Title Line One: Silicon Wafer and Method For Manufacture Thereof,

Title Line Two: and Method for Evaluation of Silicon Wafer

Total Drawing Sheets: 14
Formal Drawings: Yes
Application Type: Utility
Docket Number: 86397

Representative Information

Registration Number One: 24,003
Registration Number Two: 22,839
Registration Number Three: 28,903
Registration Number Four: 27,429
Registration Number Five: 25,060
Registration Number Six: 22,053



Registration Number Seven:	27,466
Registration Number Eight:	29,434
Registration Number Nine:	29,054
Registration Number Ten:	29,381
Registration Number Eleven:	34,044
Registration Number Twelve:	27,600
Registration Number Thirteen:	34,137
Registration Number Fourteen:	39,724
Registration Number Fifteen:	37,963
Registration Number Sixteen:	41,050
Registration Number Seventeen:	34,217

This application is based on application

Application One: PCT/JP00/05738

Filing Date: August 25, 2000

which is based on priority document

Japanese application no. 241186/1999

Filing Date: August 27, 1999